IN THE CLAIMS:

None of the claims have been amended herein.

1. (Previously Presented) A method for connecting a solder bump of an array of solder bumps on a semiconductor device and a contact site of a plurality of conductive contact sites of a member, comprising:

heating the solder bump of the array of solder bumps to a softening temperature Ts below a melting temperature of the solder bump of the array of solder bumps; and contacting the contact site of the plurality of conductive contact sites by the solder bump of the array of solder bumps of the semiconductor device using a pressure less than substantially 22 grams-force.

- 2. (Previously Presented) The method of claim 1, wherein the melting temperature of the solder bump of the array of solder bumps is T°C higher than an ambient temperature To, and wherein the softening temperature Ts is in the range of about 0.5T to 0.95T above the ambient temperature To.
- 3. (Previously Presented) The method of claim 1, wherein the solder bump of the array of solder bumps contacts the contact site of the plurality of conductive contact sites at a pressure not substantially exceeding about 10 grams-force.
- 4. (Previously Presented) The method of claim 1, wherein the solder bump of the array of solder bumps contacts the plurality of conductive contact sites at a pressure in the range of about 2 to 10 grams-force.
- 5. (Previously Presented) The method of claim 1, wherein the semiconductor device having the array of solder bumps is heated by one of hot air convection and infrared radiation.

- 6. (Previously Presented) The method of claim 1, wherein the member having the plurality of conductive contact sites is heated by one of hot air convection, conduction from a heated object, and infrared radiation.
- 7. (Previously Presented) The method of claim 1, wherein the semiconductor device and the member are placed in a temperature-controlled oven for heating to the softening temperature Ts.
- 8. (Previously Presented) The method of claim 1, wherein the semiconductor device is held in a chuck, the chuck being heated.
- 9. (Previously Presented) The method of claim 1, wherein the member is held in a chuck, the chuck being heated.
- 10. (Previously Presented) The method of claim 1, wherein the member having the plurality of conductive contact sites is heated by electrical resistance wires.
- 11. (Previously Presented) The method of claim 1, wherein the member and a substrate are mounted on a mounting board having an integral heater, the integral heater controlled to heat the member to the softening temperature Ts.
- 12. (Previously Presented) The method of claim 1, wherein the array of solder bumps comprises Sn-Pb solder having a lead content in the range of about 40 to about 98 percent, and the softening temperature Ts comprises a range of about 140 to 180°C.
- 13. (Previously Presented) The method of claim 1, wherein heating comprises predetermining a heating time X to heat the solder bump of the array of solder bumps to the softening temperature Ts, and heating for the time X.

- 14. (Previously Presented) The method of claim 1, wherein heating comprises initiating the heating, measuring a temperature of one of the member and the semiconductor device, and stopping the heating to limit a temperature of the solder bump of the array of solder bumps to no more than the softening temperature Ts.
- 15. (Previously Presented) An apparatus for connecting a solder ball to a contact site comprising:
- a first member having a solder ball thereon;
- a second member having a contact site;
- apparatus for moving the first member against the second member for contact of the solder ball to the contact site, the first member contacting the second member at a pressure less than substantially 22 grams-force for the solder ball; and
- heating apparatus for heating the solder ball and the contact site to a submelting solder-softening temperature Ts.
- 16. (Previously Presented) The apparatus of claim 15, wherein the contact site comprises one of a substantially flat surface, a recess for receiving a portion of a solder ball, and a recess having at least one projection therein for deforming a solder ball inserted therein.
- 17. (Previously Presented) A testing apparatus for a semiconductor package having a ball grid array of solder balls on a surface thereof, the apparatus comprising:
- an insert formed of generally noncompliant material, the insert having a first surface including an array of contact sites for contacting the ball grid array of solder balls and having a second surface;
- a substrate having a first surface, having a second surface, the second surface of the insert secured to the first surface of the substrate, and having a pattern of leads on the substrate for connecting to contact leads in a socket;
- electrical leads connecting the array of contact sites of the insert with the pattern of leads of the substrate;
- a test board having the socket with the contact leads connected to a testing circuit, the substrate

and the insert for insertion into the socket for contact of the pattern of leads of the substrate with the contact leads of the socket; and heating apparatus associated with at least one of the substrate, the insert, and the socket.

- 18. (Previously Presented) The apparatus of claim 17, further comprising temperature-sensing apparatus attached to one of the substrate, the insert, and the semiconductor package.
- 19. (Previously Presented) The apparatus of claim 18, further comprising a temperature controller for controlling the heating apparatus.